

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/646,608	LARSON ET AL.	
		Examiner	Art Unit	Page 1 of 1
		Fernando L. Toledo	2823	

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wolf and Tauber; Silicon Processing for the VLSI Era Volume 1: Process Technology; page 1; Lattice Press, 1986; Sunset Beach, CA
	V	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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